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PECENED TO 1200, ED

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Jack Oon Chu et al.

Serial No.: 09/683,088

Art Unit: 1765

Filed: November 16, 2001

Examiner: Not yet assigned

For: SINGLE REACTOR, MULTI-

PRESSURE CHEMICAL

VAPOR DEPOSITION FOR

SEMICONDUCTOR

DEVICES

Atty Docket: 21806/0112

SUBMISSION OF FORMAL DRAWINGS

Commissioner for Patents Washington, D.C. 20231

Sir:

The undersigned attorney respectfully submits the following 3 sheets of formal drawings of Figs. 1-3 in the above-captioned application.

Respectfully submitted,

Patrick J. Wells, Reg. No. 46,355

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